

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kamal Kishore Goundar
Appl. No. : 10/616,163
Filed : July 9, 2003
For : METHOD OF FORMING
SILICON CARBIDE FILMS
Examiner : Monica D Harrison
Group Art Unit : 2829

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 11, 2005

(Date)



Katsuhiro Arai, Reg. No. 43,315

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is an Amendment supplemental to the Amendment mailed February 22, 2005 in response to the Office Action mailed September 22, 2004.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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